

10/550278

XA-10438
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

NISHIZAWA, Hirotaka et al.

Intl. Appln. No.: PCT/JP2004/013931

Intl. Filing Date: 24 September 2004

For: SEMICONDUCTOR DEVICE

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

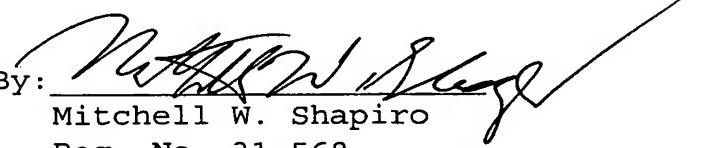
Attn: Mail Stop PCT, DO/EO/US

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any assertion as to materiality or prior art effect, the documents listed on the attached Form PTO-1449 are hereby cited.

The document on the attached List was cited in the specification, on pages 1-2, and its relevance is indicated therein.

Respectfully submitted,

MWS:skj
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September 23, 2005

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT <u>LIST OF DOCUMENTS CITED BY APPLICANT</u>				Atty. Docket No. XA-10438	Appln. No. <u>10/550278</u>		
				Applicant NISHIZAWA, Hirotaka et al.			
				Filing Date HEREWITH	Group		
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
	AB						
	AC						
	AD						
FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AE	2000-99215	04/07/00	Japan			Yes
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						
	AR						
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OTHER (including author, title, date, pertinent pages, etc.)							
	AU						
Examiner				Date Considered			
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